



PATENTS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re application of:

**Tzeng**  
**Serial No:** 09/501,114  
**Filed:** February 10, 2000  
**For:** Method of Plasma Enhanced  
Chemical Vapor Deposition  
of Diamond

**Group Art Unit:** 1762

**Examiner:** Wesley D. Markham

**Docket No.:** 220101-1010

#1319  
Hedley  
10/23/02

RESPONSE TO OFFICE ACTION

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

RECEIVED  
OCT 24 2002  
TC 1700

The Office Action mailed June 27, 2002 (Paper No. 11) has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.

AUTHORIZATION TO DEBIT ACCOUNT

It is not believed that extensions of time or fees for net addition of claims are required, beyond those, which may otherwise be provided for in documents accompanying this paper. However, in the event that additional extensions of time are necessary to allow consideration of this paper, such extensions are hereby petitioned under 37 C.F.R. § 1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to deposit account no. 20-0778.

CERTIFICATE OF MAILING (37 CFR 1.8)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope to the: Assistant Commissioner For Patents, Washington, D.C. 20231.

*Jo Bryan*  
Jo Bryan Date: Oct. 14, 2002

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01 FC:2202  
02 FC:2201

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84.00 OP